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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-340527 11/06/2001 WSL

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Verified and Acknowledged Examiner's Signature _____ Initials WSL	JAPAN	1	13	3

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## TITLE

Wafer including an In-containing-compound semiconductor surface layer, and method for profiling its carrier concentration

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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